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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/814,498	03/31/2004	Vijayakumar S. RamachandraRao	110348-135118	6442
25943	7590 02/04/2005		EXAMINER	
SCHWABE, WILLIAMSON & WYATT, P.C.			LEE, CALVIN	
PACWEST CI	ENTER, SUITES 1600-19 FH AVENUE	000	ART UNIT	PAPER NUMBER
PORTLAND,			2818	
			DATE MAILED: 02/04/2004	•

Please find below and/or attached an Office communication concerning this application or proceeding.

				(8)			
		Application No.	Applicant(s)				
·		10/814,498	RAMACHANDRARAO	et al.			
	Office Action Summary	Examiner	Art Unit				
		Lee, Calvin	2818				
Period fo	The MAILING DATE of this communica or Reply	tion appears on the cover sheet	with the correspondence address	s			
THE - Exte after - If the - If NO - Failt Any	ORTENED STATUTORY PERIOD FOR MAILING DATE OF THIS COMMUNICA nations of time may be available under the provisions of SIX (6) MONTHS from the mailing date of this communical period for reply specified above is less than thirty (30) do period for reply is specified above, the maximum statute ure to reply within the set or extended period for reply will reply received by the Office later than three months after ed patent term adjustment. See 37 CFR 1.704(b).	ATION. 7 CFR 1.136(a). In no event, however, may cation. ays, a reply within the statutory minimum of ory period will apply and will expire SIX (6) No. by statute, cause the application to become	y a reply be timely filed thirty (30) days will be considered timely. MONTHS from the mailing date of this commure BABANDONED (35 U.S.C. § 133).	nication.			
Status							
1)	Responsive to communication(s) filed	on					
-	•	☐ This action is non-final.					
3)	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposit	ion of Claims						
5)	Claim(s) 1-18 is/are pending in the app 4a) Of the above claim(s) is/are Claim(s) is/are allowed. Claim(s) is/are rejected. Claim(s) is/are objected to. Claim(s) 1-18 are subject to restriction	withdrawn from consideration.					
Applicat	ion Papers						
10)	The specification is objected to by the E The drawing(s) filed on is/are: a Applicant may not request that any objected Replacement drawing sheet(s) including the The oath or declaration is objected to b) accepted or b) objected on to the drawing(s) be held in abe e correction is required if the draw	yance. See 37 CFR 1.85(a). ing(s) is objected to. See 37 CFR 1.				
Priority (under 35 U.S.C. § 119						
12) □ a)	Acknowledgment is made of a claim for All b) Some * c) None of: 1. Certified copies of the priority do 2. Certified copies of the priority do 3. Copies of the certified copies of application from the International See the attached detailed Office action f	cuments have been received. cuments have been received in the priority documents have be I Bureau (PCT Rule 17.2(a)).	n Application No en received in this National Stag	je			
2) Notice 3) Inform	t(s) e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO mation Disclosure Statement(s) (PTO-1449 or PTo r No(s)/Mail Date	-948) Paper N	w Summary (PTO-413) No(s)/Mail Date of Informal Patent Application (PTO-152))			

U.S. Patent and Trademark Office PTOL-326 (Rev. 1-04)

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Application No: 10/814,498

Docket: 110348-135118

OFFICE ACTION

Election/Restriction

1. Claims 1-18 are pending in this application.

Restriction to one of the following inventions is required under 35 U.S.C. 121:

- (I) Claims 1-3 and 15-18, drawn to a system of wafer stacking, [class 257, subclass 686];
- (II) Claims 4-14, drawn to a method of forming a wafer system, [class 438, subclass 109].
- 2. Inventions I and II are related as product made and process of making. The inventions are distinct if either or both of the following can be shown: (1) that the product as claimed can be made by another and materially different process or (2) that the process as claimed can be used to make other and materially different product (MPEP § 806.05(f)).

In this case: (Group I compared to Group II) the packaging semiconductor system of wafer stacking can be formed not only by the claimed method of forming the stacking but also by other semiconductor process/methods, and vise versa.

3. Applicant is advised that the reply to this requirement to be completed must include an election of the invention to be examined even though the requirement is traversed (37CFR 1.143).

Contact Information

4. Any inquiry concerning this communication from the Examiner should be directed to Calvin Lee at (571) 272-1896 from 7:00AM to 5:00PM (Monday-Thursday, Eastern Time). If attempts to reach the examiner by telephone are unsuccessful, Art Unit 2825's Supervisory Patent Examiner David C. Nelms can be reached at (571) 272-1787.

Any inquiry relating to the status of this application should be directed to the Group receptionist whose telephone number is (703) 308-0596. The central fax number is (703) 872-9306 for all communications to be entered (e.g., amendments, remarks, IDS, etc.)

February 4, 2005

calomla